# UNITED STATES PATENT AND TRADEMARK OFFICE **CERTIFICATE OF CORRECTION**

PATENT NO. : 6,790,762 B1

Page 1 of 2

DATED

: September 14, 2004

INVENTOR(S): Zhiping Yin and Mark Jost

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

#### Title page,

# Item [57], ABSTRACT, replace the entire ABSTRACT with

-- The present invention relates to the formation of an ILD layer while preventing of reducing oxidation of the upper surface of a metallic interconnect. Avoidance of oxidation of the upper surface of a metallic interconnect is achieved according to the present invention by passivating the exposed upper surface of the metallic interconnect prior to formation of the ILD. In order to avoid the oxidation of an upper surface of the interconnect during the formation of an ILD layer, an in situ passivation of the upper surface of the interconnect, immediately prior to or simultaneously with the formation of the ILD layer avoids the problems of the prior art. --

Line 8, before "can range" insert -- 20 --

#### Column 4,

Line 2, change "inventing" to -- inventive --Line 48, after "14" change "is" to -- are --

Line 57, after "thereof" insert -- . --

# Column 7,

Line 50, after "deposition" change "toot" to -- tool. --

#### Column 8,

Line 10, after "carried" insert -- out --

Line 49, change "ID" to -- ILD --

### Column 9,

Line 9, after "layer" insert -- 14 --

Line 18, change "on-limiting" to -- non-limiting --

#### Column 10,

Line 56, change "absorbed onto" to -- adsorbed onto said --

# Column 11,

Line 62, change "beating" to -- heating --

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Column 13,

Line 17, remove "and;"

Signed and Sealed this

Ninth Day of August, 2005

JON W. DUDAS

Director of the United States Patent and Trademark Office